PATENT APPLICATI

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

October 17, 2003

In re the Application of

Makoto KOBAYASHI et al.

Group Art Unit: 3723

Application No.: 09/830,434

Examiner: H. Shakeri

Filed: April 26, 2001

Docket No.: 109352

For POLISHING PAD AND POLISHING METHOD FOR SEMI-CONDUCTOR WAFER

LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. \$1.17 RECEIVED

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 OCT 2 2 2003

TECHNOLOGY CENTER R3700

Sir:

Transmitted herewith is a Request for Continued Examination (RCE) in the above-identified patent application. The shortened statutory period having expired September 17, 2003, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 147449 in the amount of \$110 in payment for:

Extension fee for response within first month pursuant to §1.136(a) (\$110.00)

Extension fee for response within second month pursuant to §1.136(a) (\$420.00)

Extension fee for response within third month pursuant to §1.136(a) (\$950.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

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ectfully submitted,

Registration No. 30.02

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Christopher W. Brown Registration No. 38,025

WPB:JSA:CWB/rav

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461